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LIST OF REFERENCES CITED BY APPLICANT(S)
(Use several sheets if necessary)

APPLICANT

Nobuyoshi KOSHIDA et al.

Date Submitted to PTO: February 15, 2005

FILING DATE

February 15, 2005

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U. S. PATENT DOCUMENTS

*EXAMINER
INITIALDOCUMENT
NUMBER

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NAME

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FOREIGN PATENT DOCUMENTS

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TRANSLATION
YES NO

AJ

11-300274

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X

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62-263062

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OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

AO

H. Shinoda et al., "Thermally induced ultrasonic emission from porous silicon", Nature, Vol. 400, No. 6747, pp. 853-855, August 1999.

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AQ

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DATE CONSIDERED

03/16/2009

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of form with next communication to applicant.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /HL/